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April 1, 2004

**U.S. PATENT AND TRADEMARK OFFICE  
FACSIMILE TRANSMISSION COVER SHEET**

<b>To:</b> In re the Application of Akiro SATO	<b>FOR FILING IN THE U.S. PATENT AND TRADEMARK OFFICE</b>
Application No.: 09/424,500	
Filed: February 22, 2000	Group Art Unit: 2825
For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE	Docket No.: 104788

Examiner: G. Lee Facsimile: (703) 872-9306From: James A. Oliff Linda M. Saltiel  
Reg. No. 27,075 Reg. No. 51,122Prepared By: mlv Number of Pages Sent (Including cover sheet): 3**Comments:**Sent by: mlv

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**PT RECEIPT FOR FILING OF PAPERS**

► Mail Room (Regular Delivery)

The following papers have been filed:

RCE; AND CHECK NO. 144081 (\$750.00).

Name of Applicant: Akio SATO

Serial No.: 09/424,500

Attv. File No.: 104788

Title (New Cases):

Sender's Initials: JAO:LMS



**PATENT OFFICE DATE STAMP**

5/10

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AND RETURNED BY MESSENGER**

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akiro SATO

Group Art Unit: 2825

Application No.: 09/424,500

Examiner: G. Lee

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For: METHOD OF MANUFACTURING  
SEMICONDUCTOR DEVICE, MOLDING  
DEVICE FOR SEMICONDUCTOR DEVICE,  
AND SEMICONDUCTOR DEVICE

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**OFFICIAL****LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination and entry and consideration of the Amendment After Final Rejection submitted on April 21, 2003. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 144081 in the amount of ☒ \$750.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,



James A. Oliff  
Registration No. 27,075

Linda M. Saltiel  
Registration No. 51,122

JAO:LMS/rxg

Date: July 11, 2003

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